METHOD AND APPARATUS FOR EXTRATION, DETECTION, AND CHARACTERIZATION OF VAPORS FROM EXPLOSIVES, TAGGANTS IN EXPLOSIVES, CONTROLLED SUBSTANCES, AND BIOHAZARDS

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U.S. PATENT DOCUMENTS
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Bicchi et al. “Headspace sorptive extraction (HSSE), stir bar sorptive extraction (SBSE), and solid phase microextraction (SPME) applied to the analysis of roasted arabica coffee and coffee brew.” J. Agric. Food Chem. (2002) 50 449-459 *

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ABSTRACT
An improved method of extraction, detection, and characterization of a vapor from an explosive, a tagnant in an explosive, a controlled substance, a biohazard, and mixtures thereof uses a new and improved SPME device for extraction and ion mobility spectrometry for detection and characterization. The new and improved SPME device has an increased capacity to sorb a target vapor. The increased sorption of vapor provides for more accurate detection by an ion mobility spectrometer. A SPME device having increased surface area may be exposed to an atmosphere in an enclosure containing a test object or a volume of gas that was in contact with the test object to allow for sorption of the target vapor and then introduced into an IMS for more accurate detection and characterization of the vapor due to the increased sorption of the vapor by the SPME device described herein.

5 Claims, 4 Drawing Sheets


* cited by examiner
FIG. 4

FIG. 5

FIG. 6
METHOD AND APPARATUS FOR EXTRACTION, DETECTION, AND CHARACTERIZATION OF VAPORS FROM EXPLOSIVES, TAGGANTS IN EXPLOSIVES, CONTROLLED SUBSTANCES, AND BIOHAZARDS

CROSS-REFERENCE TO RELATED APPLICATIONS


STATEMENT OF GOVERNMENT INTEREST

This invention was made with government support under grant 2006-DN-BX-K027 awarded by the National Institute of Justice. The government has certain rights in the invention.

BACKGROUND

Ion mobility spectrometry (IMS) is a rugged, inexpensive, sensitive, field portable technique for the detection of organic compounds. It is widely employed in ports of entry and by the military as a particle detector for explosives and drugs of abuse. Many organic high explosives do not have a high enough vapor pressure for effective vapor sampling. However, these explosives and their commercial explosive mixtures have characteristic volatile components detectable in a headspace when contained. In addition, taggants are added to commercially-manufactured explosives to aid in detection through headspace sampling. Solid phase microextraction (SPME) is an effective extraction technique that has been successfully employed in the field for the absorption and/or desorption of a variety of compounds. SPME can easily extract these compounds from the headspace for IMS vapor detection.

In 1996, Congress passed the Anti Terrorism Bill, which requires the addition of detection taggants to plastic explosive compounds and the ban of sale or import of plastic explosives that do not contain a detection agent [Public Law 104-132, Antiterrorism and Effective Death Penalty Act of 1996; Section 603, Apr. 24, 1996]. A detection tagnant is a solid or liquid vapor emitting substance added to an explosive material to facilitate discovery before detonation. A detection tagnant can easily be detected by explosive vapor detectors, such as ion mobility spectrometers (IMS). IMS are currently used as particle detectors requiring the manual transfer of particles from a suspect area and thermal desorption into the spectrometer.

Many organic high explosives, particularly those found in plastic explosives, do not produce a significant vapor pressure to allow headspace vapor detection, especially in the field [R. G. Ewing, C. J. Miller, Field Anal. Chem. Technol., 5:215-221 (2001)]. The International Civil Aviation Organization (ICAO) has designated the detection taggant compounds as the following four compounds in the indicated concentrations by mass: 0.5% 2-nitrotoluene (2-NT), 0.5% 4-nitrotoluene (4-NT), 0.1% 2,3-dimethyl-2,3-dinitrotoluene (DMNB), and 0.2% ethylene glycol dinitro (EGDN) [Convention on the Marking of Plastic Explosives for the Purpose of Detection, http://www.mcgill.ca/files/iass/montreal1991.pdf, accessed Feb. 6, 2008]. These compounds were selected because they do not commonly found in nature, they do not hinder the explosive properties of the tagged compound, they continue to release their vapors at a steady rate for 5 to 10 years, they do not present a significant environmental hazard, and they do not readily adhere to common substances the taggant may come in contact with [J. Yanon, Forensic Applications of Mass Spectrometry, CRC Press, Boca Raton, Fla., 1995]. In addition to taggant detection to determine if an improvised explosive device is present, there are also additional odor signature compounds present in significant amounts for detection [M. Williams, J. M. Johnston, M. Cicoria, E. Paletz, L. P. Wagoner, C. Edge, S. F. Hallowell, Proc. SPIE, 35:291-301 (1999)]. These odor signature compounds can be extracted using SPME and detected by IMS [J. M. Perr, K. G. Furton, J. R. Almirall, J. Sep. Sci., 28:177-183 (2005). 2. H. Lai, P. Guerra, M. Joshi, J. R. Almirall, J. Sep. Sci., 31: 402-412 (2008)].


IMS is a presumptive detection method for organic compounds that is extremely fast, straightforward to use, low cost, with clear-cut data interpretation, excellent sensitivity, and low power demands. Run times for commercial IMS range from 1 to 7 seconds. IMS machines have a large installed base of over 10,000 commercial instruments and 50,000 military instruments conducting over 10,000,000 analyses per year [K. Cottingham, Anal. Chem., 75:435A-439A (2003)]. The false positive rate for swabbing of suspected areas is reported to be less than 1% while the false positive rate for air sampling of suspected areas is less than 0.1% [Jemison, Conabrand (Drug and Explosive) Detection and Identification System User's Manual revision 3.1., GE Ion Track Instruments, Wilmington, Mass. (1999)]. For example, when seventeen of the most likely false positives for 2,4,6-trinitrotoluene (2,4,6-TNT) were studied, it was found that only seven of those were detected by the IMS and upon careful analysis, the compound that displayed the most similar mobility to TNT, 4,6-dinitro-o-cresol (4,6-DNC), did not produce a false positive [L. M. Matz, P. S. Tomatore, H. H. Hill, Talanta, 54:171-179 (2001)]. IMS has also been evaluated as a field screening application and found to have a number of advantages over other field deployable techniques [H. H. Hill, G. Simpson, Field Anal. Chem. Technol., 1:119-134 (1997)].

In IMS, ions are separated and recognized on the basis of their mobility values. Some instruments can analyze only positive or negative ions in a determination, while other instruments can analyze both positive and negative ions in the same analytical determination. The detection of explosives and taggants are typically conducted in the negative ion mode. Mobility (K in cm$^2$/V s) is determined using the drift velocity (vd in cm/s) of the ion through a heated drift tube and a weak electric field (E in V/cm) that the ion is exposed to when inside the heated drift tube (vd = E/K). Ionization occurs in the reaction region when a 63Ni source initiates ionization by emitting β particles. The β particles trigger a cascade of ionization reactions, either with the air or with a dopant gas present in the ionization region, to produce reactant ions. The reactant ions interact with the sample through

Also during IMS, an electronic gate opens at timed intervals throughout the run to allow the ions to enter the drift region for separation to occur. The opening of the electronic gate begins the timing of the ion’s flight time to reach the detector in order to calculate the drift velocity. A linear potential drop exists in the drift region to move the reactant and product ions towards the detector. Neutrals and ions of the opposite charge being analyzed are swept out of the drift region by a counter-current flow of drift gas. A planar mass spectrometer results as a plot of the current measured at the collector electrode with respect to time in the milliseconds (ms) time frame. The General Electric Ion Track Itemiser® 2 collects one planar mass every 100 ms. For a 7 s run, 70 planar maps are recorded. The 70 collected planar maps then undergo a data deconvolution step in which a representative planar mass spectrometer is produced. An intensity map view all the planar maps collected during one run stacked on each other showing height as intensity. Dark areas represent peaks while lighter areas represent troughs. A single planar mass can be imported into Excel and graphed.

An important factor that affects mobility is the collisional cross-sectional area (Qd in A²). The mean free path of an ion with a large collisional cross-section is shorter than those of a smaller collisional cross-section. If two molecules have the same collisional cross-section, the heavier molecule will have a longer mean free path due to its slower velocity. The dopant gas and air within the drift tube affect the drift velocity (vd) by collisions, making IMS a quasi mass analyzer but instead of using only mass to charge (m/z) it uses three different parameters: shape (collisional cross-section), mass, and charge.


SPME is a very effective tool for the extraction of taggants from headspace samples under ambient environmental conditions that can also be used for remote sampling. Ion mobility spectrometry is a very effective tool for detecting trace amounts of explosives and explosive taggants under ambient environmental conditions [M. Nambayah, T. I. Quickenden, Talanta, 63:461-467 (2004)]. Ion mobility spectrometers have been successfully interfaced to other sample introduction techniques such as a solid phase extraction (SPE) [T. L. Buxton, P. B. Harrington, Appl. Spectrosc., 57:223-232 (2003)], gas chromatography (GC) [J. P. Dworzanski, W. H. McClennan, P. A. Cole, S. N. Thornton, H. L. C. Meuzelaar, N. S. Arnold, A. P. Snyder, Field Anal. Chem. Technol., 1:295-305 (1997)], and liquid chromatography (LC) [S. J. Valentine, M. Kuchcina, C. A. S. Barnes, D. E. Clemmer, Int. J. Mass Spectrom., 212:97-109 (2001)].

A SPME-IMS interface has been created to couple the extraction efficiency of SPME to the detection capability of IMS. The demand for this sort of field portable, remote, reliable sampling is high [J. Yoon, Anal. Chem., 75:105A-105A (2003)]. The SPME-IMS interface shown meets this need by extracting vapors from explosives, taggants in explosives, controlled substances, biohazards, and mixtures thereof (detectable target vapors or detectable vapors) from a headspace for subsequent detection by a commercially available IMS in a simple, rapid, sensitive, and inexpensive manner.

Ranges may be expressed herein as from “about” or “approximately” one particular value and/or to “about” or “approximately” another particular value. When such range is expressed, another embodiment includes the one particular value and/or to the other particular value. Similarly, when values are expressed as approximates, by use of the antecedent “about” it will be under that the particular value forms another embodiment.

SUMMARY OF THE DISCLOSURE

An apparatus and method for extraction of a detectable target vapor from a volatile compound such as an explosive, taggent in an explosive, controlled substance, biohazard, and mixtures thereof and methods for subsequent detection and characterization of the target vapor by an ion mobility spectrometry (IMS) are disclosed. The apparatus may comprise a tube having an inlet; a resistor for heating the tube; a connector fitted to the inlet; a septum fitted and sealed to the connector; and a new and improved solid phase microextraction (SPME) device adapted to be first exposed to an atmosphere that has been exposed to an object that may contain a volatile compound such as an explosive, a taggent in an explosive, a controlled substance, a biohazard, or mixtures thereof, thereby allowing the SPME device to adsorb and/or adsorb a detectable target vapor from the volatile compound. The SPME device may have increased surface area to allow for increased absorption and/or adsorption of the vapor. The SPME device may be further adapted to be introduced into the
apparatus for volatilization and introduction of the vapor into a sample receiving area of an IMS for detection and characterization of the target vapor.

Also disclosed is a method for extraction, detection, and characterization of a vapor a volatile compound such as an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof. The method may comprise the steps of: (1) exposing a SPME device to an atmosphere in an enclosure containing a test object, thereby allowing the SPME device to absorb and/or adsorb the target vapor emitted from said object thereby concentrating the target vapor in and/or on the SPME device; and (2) introducing the SPME device into a sample receiving area of an apparatus for volatilization of the concentrated target vapor from the SPME device and introduction of the concentrated target vapor into an IMS for detection and characterization of the vapor.

Another method for extraction, detection, and characterization of a vapor from a volatile compound such as an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof may include the steps of: (1) contacting a test object with a volume of gas to form a mixture of said gas with a detectable vapor; (2) exposing a SPME device to said gas to allow for absorption and/or adsorption of the detectable target vapor; and (3) introducing the SPME device into an apparatus for thermal desorption and introduction of the target vapor into an IMS for detection and characterization of the target vapor.

The SPME device described herein has increased surface area adapted for improved absorption and/or adsorption of a vapor from a volatile compound such as an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof and subsequent, more reliable detection and characterization by an IMS. In accordance with the SPME devices and detection methods used and described herein, the SPME devices may include a substrate and a volatile compound sorptive coating disposed on the substrate and capable of absorbing and/or adsorbing a vapor from an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof in an amount sufficient for detection in an IMS. In accordance with a preferred embodiment, the SPME device may have a surface area of at least 50 mm².

A method of preparing the SPME devices having increased surface area is also disclosed. In one embodiment of the SPME devices and detection methods described herein, the SPME devices are prepared for accurate detection by first cleansing the substrate, e.g., with a cleansing agent or mixture, prior to coating the substrate; preparing a volatile compound sorptive coating mixture; and then coating the substrate with the volatile compound sorptive coating mixture to form a volatile compound sorptive coating that is capable of absorbing and/or adsorbing a target vapor from a volatile compound such as an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof in an amount sufficient for detection in an IMS.

A new and improved method of extracting a detectable target vapor from a volatile compound such as an explosive, a taggart in an explosive, a controlled substance, a biohazard, or mixtures thereof using a new and improved SPME device having an increased capacity to sorb the target vapor is also disclosed. The improved absorption and/or adsorption of the vapor allows for better extraction of the target vapor and provides for more accurate detection and characterization by an IMS. In one embodiment of the new and improved method, the method may include preparing a new and improved SPME device, having increased surface area, and exposing the SPME device to an atmosphere in an enclosure containing a test object or a volume of gas that was in contact with the test object to allow for absorption and/or adsorption of the target vapor. The SPME device may then be introduced into a sample receiving area of an IMS for more accurate detection and characterization of the target vapor due to the increased absorption and/or adsorption of the target vapor by the SPME devices described herein.

The devices, apparatus, and methods described herein, together with further objects and attendant advantages, will be best understood by reference to the following detailed description, taken in conjunction with the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWING

FIG. 1 is a first schematic representation of the SPME-IMS interface.
FIG. 2 is a second schematic representation of the SPME-IMS interface, which also includes an interface housing and related components.
FIG. 3 is a front perspective view of an SPME-IMS interface in accordance with the present disclosure.
FIG. 4 is a perspective view of a substrate of a SPME device in accordance with the present disclosure.
FIG. 5 is a cut-away view of a SPME device in accordance with the present disclosure.
FIG. 6 is a perspective view of the SPME device of FIG. 5 disposed in the sample receiving area of an IMS.

DETAILED DESCRIPTION OF DRAWINGS

Referring now to FIG. 1, a solid phase microextraction ion mobility spectrometry (SPME-IMS) interface 10 is shown. The SPME-IMS interface 10 is a second generation prototype that was constructed for less than $1000 (US). An aluminum tube 12 was machined to form an inlet 14 (see FIG. 2) that can be heated using a resistor 16. A pentistat 22 (see FIG. 2) was used to provide current to the resistor 16, for example. A first aluminum cylindrical heating block 18 and a second aluminum heating block 20 may also be disposed on or near opposite ends of the aluminum tube 12, as shown in FIGS. 1 and 2.

The inlet 14 was coated with a +1200 A (Silcosteel®) layer treatment (Restek, Bellefonte, Pa.) to deactivate the surface. Ultra high purity helium carrier gas (Air Products, Allentown, Pa.), the heat generated by the resistor 16, and the first and second cylindrical heating blocks 18, 20 were used to desorb the analytes off a SPME device 106. A calibrated 150 mm aluminum 15-turn high-accuracy valve flow meter from Gilmet® Instruments (Barrington, Ill.) was used to control the flow of helium through the SPME-IMS interface 10. Of course, various other types of valve flow meters may be used in conjunction with the interface 10 of the present invention, as this particular model is representative only. A Swagelok union “T” connector 24, purchased from Florida Fluid Systems Technologies, Inc. (Sunrise, Fla.) was fitted onto the sample thermal desorption inlet 14 (see FIG. 3). For example, a Swagelock Male Run Tee, ½ in. Tube ODx½ in. Male NPTx½ in. Tube OD may be used. A 5 mm Thermogreen septum 26 was machine punched out from an 11 mm Thermogreen Supelco (Bellefonte, Pa.) septum using a punch. The 5 mm septum 26 was fitted into one of the caps on the union “T” connector 24 and sealed in place using the back ferrule of the union “T” connector. Again, of course, other types of septa and connectors may be used in accordance with the interface 10 of the present invention, as the aforementioned components, while used in the SPME-IMS interface 10 described herein, are representative only. The total length of the SPME-IMS device is 11 cm.
Referring now to Fig. 2, the SPME-IMS interface 10 further includes a housing 40. The housing 40 may be formed of metal, a metal alloy, or other material. A thermocouple 30 is also shown (see also Fig. 1), which senses the temperature of the resistor 16 based on the principle that voltage is produced when two dissimilar metals are joined. The peltier 22 may be disposed on a first side 40a of the housing 40, as shown in Fig. 2, for example. A fuse 32 and a power switch 36 are disposed on a second side 40b of the housing 40, and a power cord 34 is disposed on a third side 40c of the interface housing 40. Of course, the peltier 22, the fuse 32, the power switch 36, and the power cord 34 may alternatively be disposed on other areas of the housing 40, resulting in alternative configurations that would not depart in the least from the spirit and scope of the present invention. An ion mobility spectrometer inlet nozzle 28, which is attached to interface 10 near the second aluminum cylindrical heating block 20, is also disposed on the third side 40c of the housing 40. Lastly, an insulating material 42, such as a glass wool insulating material, encircles the resistor 16.

Figs. 2-3 show a preferred embodiment of an SPME-IMS interface 10 in accordance with the present invention. Interface 10 has an outer housing 40 for mounting the various components of the interface 10. Flexible tubing 41 conveys a carrier gas from a source (not shown) to carrier gas inlet 25. Helium is a preferred carrier, but any other non-reactive gases could also be used.

A septum 26 is adapted to receive a SPME device 106 (not shown). Upon exposure to heat, vapors emitted from the SPME device 106 are conveyed by the carrier gas through connector 24. Referring to Fig. 3, heat may be supplied by a resistor 16 in the form of resistor block 16a, for example.

In accordance with the apparatus and methods described herein, a SPME device 106 having increased capacity for absorption and/or adsorption of a detectable target vapor is first exposed to air or other gaseous atmosphere in an enclosed space containing an object, e.g., a suitcase or other container containing a volume sufficient to contain an explosve, biohazard, or controlled substance, allowing for sorption (i.e. absorption and/or adsorption) of the target vapor. The SPME device 106 is then introduced into the interface 10 for volatilization and introduction of the concentrated target vapor into the IMS. Volatilization of a detectable quantity of the target vapor can be achieved by thermal desorption. The IMS then detects and characterizes the target vapor to indicate whether a volatile compound such as an explosive, a tagnant in an explosive, a controlled substance, a biohazard, or mixtures thereof are present in the object. Using the SPME device 106 and methods herein described, more accurate detection can be achieved.

A SPME device’s 106 capacity for absorption and/or adsorption of a detectable target vapor as well as its sensitivity may be enhanced by increasing the amount of SPME-phase able to participate in the absorption and/or adsorption of the target vapor. By increasing the surface area of the SPME device 106, the amount of SPME-phase able to participate in absorption and/or adsorption of the vapor is increased without appreciably increasing sorption time. The SPME device 106 may also be sized for use in a sample receiving area 112 of a conventional IMS 110, thereby providing for a low cost method of performing SPME and IMS in combination.

Referring to Fig. 4, the SPME device 106 comprises a substrate 100 and a volatile compound sorptive coating 108. The substrate 100 may be, for example, substantially planar, and may have the shape of a rectangle, a square, or any other suitable geometry. Preferably, the substrate 100 has a disc shape. The substrate 100 may be formed of any suitable material such as, for example, a metal, plastic, or ceramic. For example, the substrate 100 may be glass, fused silica, aluminum, or stainless steel. The substrate 100 may be flexible or rigid. Preferably, the substrate 100 has a size and shape that substantially corresponds to the desired size and shape of the SPME device 106. Preferably, the SPME device 106 has a flat disc shape.

The substrate 100 has first and second major surfaces 102. The first and second major surfaces 102 may, for example, be planar. Preferably, the first and second major surfaces 102 have a circular shape. However, the first and second major surfaces 102 may have any other suitable shape, such as for example, a square or rectangular shape. The first and second major surfaces 102 may each have a surface area of from approximately 5 to 2500 mm². Preferably, the first and second major surfaces 102 each have a surface area of from approximately 50 to 1000 mm². Most preferably, the first and second major surfaces 102 each have a surface area of from approximately 250 to 500 mm².

The substrate 100 may have one or more side surfaces 104 disposed between and integrally connected to the first and second major surfaces 102. The side surfaces 104 may be, for example, planar or rounded. The SPME device 106 may have a thickness of approximately 0.5 to 5 mm. Preferably, the SPME device 106 may have a thickness of approximately 0.5 to 2 mm.

Referring to Fig. 5, any one or more of the surfaces of the SPME device 106 can be coated with a vapor sorption medium, such as poly(dimethylsiloxane) to form a volatile compound sorptive coating 108. For example, an entire surface of the substrate 100, including the first and second major surfaces 102 and the one or more sides surfaces 104 may be coated with the vapor sorption medium such that the volatile compound sorptive coating 108 is disposed over the entire surface of the substrate 100. Alternatively, for example, only the first and second major surfaces 102 may be coated with the vapor sorption medium.

The volatile compound sorptive coating 108, is capable of absorption and/or adsorption of target vapors, such as vapors from explosives, tagnants in explosives, controlled substances, biohazards, or mixtures thereof. The volatile compound sorptive coating 108 may have a thickness of approximately 20 to 200 μm.

Sorption media capable of sorbing (absorbing or adsorbing) a detectable quantity of target vapors include, for example, carbowax, carboxen, divinylbenzene, poly(dimethylsiloxane) (PDMS), sol-gel PDMS, carbowax/polyethylene glycol (CW/PEG), carbowax/temlated resin (CW/TPR), carboxen/polydimethylsiloxane (CAR/PDMS), divinylbenzene/carboxen/polydimethylsiloxane (DVB/CAR/PDMS), polydimethylsiloxane/divinylbenzene (PDMS/DVB), and polycrlylate(PA), and the like. The preferred sorption medium is an absorbent siloxane coating, particularly PDMS and sol-gel PDMS. Any sorption media capable of forming a volatile compound sorptive coating 108 that is capable of absorbing and/or adsorbing target vapors may be used.

The SPME device 106 may have a total surface area, for example, of at least 25 mm². Preferably, the SPME device 106 may have a surface area of from approximately 25 to 5000 mm².

The surface area of the volatile compound sorptive coating 108 of the SPME device 106 is at least 25 mm². Preferably, the volatile compound sorptive coating 108 has a surface area of from approximately 25 to 5000 mm². More preferably, the volatile compound sorptive coating has a surface area of approximately 500 to 1000 mm².
Referring to FIG. 6, the SMPE device 106 may be sized, for example, to substantially fit in a sample receiving area 112 of a conventional IMS 110. By sizing the SMPE device 106 to fit in the sample receiving area 112 of a conventional IMS 110, SMPE-IMS can be performed in combination without modification of the IMS 110 and, thus, at lower cost. Additionally, the SMPE-IMS interface 10 may, for example, be adapted for loading of a SMPE device 106. The SMPE-IMS interface 10 may, for example, be adapted for loading of a SMPE device 106 having a size and a shape that does not fit in the sample receiving area 112 of a conventional IMS 110; for example, a SMPE device 106 that is larger than the sample receiving area 112 of a conventional IMS 110.

To form the SMPE device 106, the substrate 100 having a desired size and geometry is prepared. The first and second major surface 102 and side surfaces 104 of the substrate 100 may be prepared, for example, by exposing the substrate 100 to a cleansing agent or mixture. The cleansing mixture may, for example, be a solution of H₂SO₄ and H₂O₂. The solution may consist, for example, of an approximately 2 to 1 ratio of H₂SO₄ to H₂O₂. The substrate 100 may then be rinsed using deionized water. If, for example, a glass substrate is used, the substrate 100 may be further prepared by placing the substrate 100 into a sodium hydroxide (NaOH) solution to expose the silanols on the glass to allow for proper bonding of the volatile compound sorptive coating mixture. The glass substrate may then be rinsed using deionized water. If, for example, a metal substrate is used, a metal surface preparation may be completed. See A. Franquet, H. Terryn and J. Vereecken. Surf. Interface Anal., 36: 681-684 (2004). The metal substrate may be prepared by immersing the substrate in a mixture of an approximately 1 to 5 ratio of perchloric acid to ethanol at a temperature of approximately 10°C. The metal substrate is then ultrasonically cleaned by dipping it successively into hexane, acetone, and methanol. The metal substrate is held in each chemical for approximately 5 minutes. An alkaline cleaning may then be performed by immersing the ultrasonically cleaned substrate for approximately 8 minutes at a temperature of approximately 65°C. In a 7.5 vol. % AC1055 (Chemetall, Frankfurt, Germany) solution using distilled water as a solvent. The metal substrate are then thoroughly rinsed with distilled water and blow-dried.

A volatile compound sorptive coating mixture may be prepared or obtained. If, for example, the desired volatile compound sorptive coating 108 is poly(dimethylsiloxane) (PDMS), a coating mixture that includes chlorine terminated poly(dimethylsiloxane) and dichloromethane may be prepared. Preferably, the coating mixture includes an approximately 3 to 1 ratio of chlorine terminated poly(dimethylsiloxane) to dichloromethane. Any other volatile compound sorptive coating mixture that is suitable for absorption and/or adsorption of a target vapor from a volatile compound as such as an explosive, a taggant in an explosive, a controlled substance, a biohazard, or mixtures thereof may be used. The volatile compound sorptive coating mixture may also be prepared using, for example, a sol-gel technique. The sol-gel process involves the transition of a system from a liquid “sol” to a solid “gel” phase. In this process, the precursor, MTMOS, for example, is subject to hydrolysis and poly-condensation to form a colloidal suspension (“sol”). If, for example, a PDMS coating is desired, a PDMS coating mixture may be prepared by sol-gel technique. The sol-gel preparation of a PDMS coating mixture may include, for example, dissolving vinyl terminated PDMS in MeCl₂, adding MTMOS, PMHS, and TFA.

The substrate 100 is coated with the volatile compound sorptive coating mixture to form a volatile compound sorptive coating 108. The substrate 100 may be coated by spin coating or dip coating, for example. If the substrate 100 is glass, the substrate 100 may be coated, for example, with PDMS using an oxygen-plasma treatment. Any other suitable coating method may be used as well. To coat the substrate 100 by dip coating, for example, the substrate 100 is immersed in the volatile compound sorptive coating mixture and held for a period of time. The substrate 100 is then withdrawn from the volatile compound sorptive coating mixture and the solvent is allowed to evaporate. To coat the substrate 100 using a spin coating method, for example, the volatile compound sorptive coating mixture is deposited on the substrate 100. The substrate 100 is then rotated at high speeds to distribute the volatile compound sorptive coating mixture by centrifugal force. Rotation is continued until the desired thickness of a volatile compound sorptive coating 108 is achieved. The coating process may further include curing the coated substrate 100. The coated substrate 100 may be cured, for example, in an oven under nitrogen.

The volatile compound sorptive coating 108 disposed on the substrate 100 is capable of absorbing and/or adsorbing a target vapor from a volatile compound such as an explosive, a taggant in an explosive, a controlled substance, a biohazard, or mixtures thereof. Preferably, the volatile compound sorptive coating 108 is PDMS or sol-gel PDMS. Any volatile compound sorptive coating 108 suitable for absorbive and or adsorptive of target vapors from a volatile compound such as an explosive, a taggant in an explosive, a controlled substance, a biohazard, or mixtures thereof may be used. Other suitable volatile compound sorptive coatings 108 may include, for example, carbowax, carboxan, divinylbenzene (DVB), polyurethane, and polyacrylate. Mixed phase volatile compound sorptive coatings 108 may also be used and may include, for example, carbowax/polyethylene glycol (CW/PEG), carbowax/templated resin (CW/TPR), carboxen/polydimethylsiloxane (CAR/PDMS), divinylbenzene/carboxen/polydimethylsiloxane (DVB/CAR/PDMS), polydimethylsiloxane/divinylbenzene (PDMS/DVB).

The SMPE device 106 may be used for sorption of any vapor capable of being sorbed and concentrated therein or thereon, preferably, a target vapor from a volatile compound such as an explosive, a taggant in an explosive, a controlled substance, a biohazard, or mixtures thereof by absorption and/or adsorption of the vapor by the volatile compound sorptive coating 108. To extract a target vapor from a volatile compound, the SMPE device 106 may be first exposed to air or another gaseous atmosphere in an enclosed space containing an object to allow for absorption and/or adsorption of one or more target vapors and concentration of the target vapor in and/or on the SMPE device 106. Alternatively, a test object may be contacted with a volume of gas and the SMPE device 106 may be exposed to the volume of gas to allow for absorption and/or adsorption of vapors contained in the volume of gas. The SMPE device 106 may then be introduced into a sample receiving area 112 of an IMS 110 for volatileization of the target vapor from the SMPE device 106 and introduction of the target vapor into the IMS 110. The IMS 110 can then detect and characterize the vapor. Thermal desorption may be used, for example, to introduce the vapor into the IMS 110.

The combination of SMPE and IMS can have a large range of applications; all that is required is extraction of the target vapor by the SMPE-phase and the ability to detect the vapor by IMS. As described, the application of the SMPE-IMS interface 10, the new and improved SMPE device 106, and the method of extraction, detection, and characterization will allow for the vapor sampling of volatile compounds such as explosives, taggants in explosives, controlled substance, bio-
hazards, or mixtures thereof and detection and characterization of the vapor samples by IMS. The combination of SPME and IMS using the new and improved SPME devices \textsuperscript{106} may allow for more accurate detection and characterization and may, also, simplify the detection process, and allow for rapid field sampling of large rooms and containers.

Moreover, because the SPME device \textsuperscript{106} has increased amount of SPME-phase able to participate in extraction it can absorb and/or adsorb an increased amount of the target vapor and thereby improve sensitivity and accuracy of the detection method without appreciably increasing the extraction time. The improved sensitivity may allow for detection and characterization of characteristic vapors that cannot be detected by prior art methods or devices.

The present invention has been described with reference to specific examples, which are intended to be illustrative only and not to be limiting of the invention. It will be apparent to those of ordinary skill in the art that changes, additions, and/or deletions may be made to the disclosed embodiments without departing from the spirit and scope of the invention.

What is claimed:

1. A method for extraction, detection, and characterization of a volatile compound, comprising the steps of:

exposing a solid phase microextraction (SPME) device to an atmosphere in an enclosure containing a test object, thereby allowing for sorption of a volatile compound within the test object, wherein the SPME device comprises a volatile compound sorptive coating disposed on a substrate, the substrate has a first surface and an oppositely disposed second surface, the SPME device has a thickness as measured by the distance between the first and second surfaces of 0.5 mm to 2 mm, and the volatile compound sorptive coating is capable of sorbing a volatile compound from a material selected from the group consisting of explosives, taggants in explosives, controlled substances, biohazards, and mixtures thereof; and

introducing the SPME device into a sample receiving area of an ion mobility spectrometer (IMS) for volatilization of the vapor from the SPME device and introduction of the volatile compound into the ion mobility spectrometer for detection and characterization of the volatile compound, wherein the SPME device resides in the sample receiving area of the IMS such that the first and second surfaces are concentric with the sample receiving area.

2. The method of claim 1, comprising volatilizing the vapor from the SPME device by thermal desorption.

3. The method of claim 1, comprising coating the substrate with the volatile compound sorptive coating mixture to form a poly(dimethylsiloxane) volatile compound sorptive coating.

4. The method of claim 1, further comprising exposing the SPME device to a volume of gas that contacted the test object.

5. The method of claim 1, wherein the first and second surfaces of the SPME device are circular and planar.

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